

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Satoshi NAKAMAE

Group Art Unit: 3728

Application No.: 10/568,580

Examiner: C. CHEUNG

Filed: February 17, 2006

Docket No.: 127096

For: SUBSTRATE STORAGE CASE

APPLICANT'S SUMMARY OF SUBSTANCE OF INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant appreciates the courtesies shown to Applicant's representative by Examiners Cheung and Wu in the November 19, 2009 interview. Applicant's separate record of the substance of the interview is incorporated into the following remarks.

Applicant's representative argued that none of the prior art of record describes, or renders obvious, at least the feature of claim 1 reciting "...each of the pair of support portions in each of the lower support parts and in each of the upper support parts including an oblique face being in contact with a corner edge of the substrate to clamp the substrate from a lower side and from an upper side between the support portions of the lower support parts and the support portions of the upper support parts so that vertical and horizontal movement of the substrate is substantially prevented."

The Examiners agreed that claim 1 distinguishes over the prior art of record.

Favorable reconsideration and prompt allowance of claims 1 and 5-12 are earnestly solicited.

Should the Examiner believe that anything further would be desirable in order to place this application in even better condition for allowance, the Examiner is invited to contact the undersigned at the telephone number set forth below.

Respectfully submitted,



James A. Oliff
Registration No. 27,075

Andrew B. Whitehead
Registration No. 61,989

JAO:ABW/abw

Date: November 23, 2009

OLIFF & BERRIDGE, PLC
P.O. Box 320850
Alexandria, Virginia 22320-4850
Telephone: (703) 836-6400

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